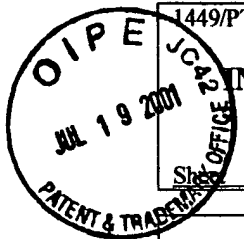


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Patent and Trademark Office U.S. DEPARTMENT OF COMMERCE



1449/PTO	U.S. Department of Commerce Patent and Trademark Office	Application No. : 09/815,493
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Filing Date : March 22, 2001
		First Named Inventor : Hideo ABE et al.
		Group Art Unit : 2661
		Examiner Name :
		Attorney Docket No. : FUJH 18.473
Sheet 1 of 1		

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	U.S. Patent Document	Kind Code if known ²	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	Foreign Patent Document Office ³ Number ⁴ Kind Code ⁵ (if known)	Country	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear
		4-351039	JP	NEC CORP.	12/04/1992	
		5-83290	JP	NEC. COMMUN.	04/02/1993	
		6-224932	JP		08/12/1994	
		8-46629	JP	NEC. CORP.	02/16/1996	
		8-65307	JP		03/08/1996	
		9-34816	JP	TOSHIBA CORP.	02/07/1997	
		9-312652	JP		12/02/1997	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

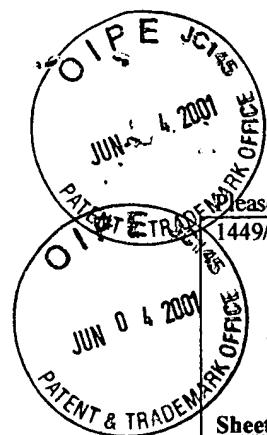
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), data, page(s), volume-issue number(s), publisher, country, where published, source.	Applicant check here if English language translation attached ^T
		The Institute of Electronics, Information and Communication Engineers, March 1997, Vol. 2, Page 410, AAL-1 CLAD Processing Method Using a Shared Cell Storage, T. Kaganoi et al.	

Examiner Signature		Date Considered	4/15/04
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¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that Issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.1⁶ if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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1449/PTO

U.S. Department of Commerce
Patent and Trademark Office

Application No. : 09/808,060

Filing Date : March 14, 2001

First Named Inventor : N. Kajizaki et al.

Group Art Unit : 2661

Examiner Name :

Attorney Docket No. : FUJA 18.463

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Sheet 1 of 1

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Examiner Initials	Cite No. ¹	U.S. Patent Document	Kind Code if known ²	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear

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Examiner Initials	Cite No. ¹	Foreign Patent Document Office ³ Number ⁴ Kind Code ⁵ (if known)	Country	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear
		1-241243	JP	Mitsubishi Electric	09/26/1989	
		2-166856	JP	Fujitsu Ltd.	06/27/1990	
		6-37793	JP	NEC Corp.	02/10/1994	
		7-177176	JP	NEC Corp.	07/14/1995	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

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